# Monthly LabAdviser update: 11/4 2016

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| Updated Subject | Contributor | Link to the updated pages |
| **Lithography main page**  Two new section on the lithography main page:   * Lithography Tool Package Training (new course in lithography – take a look) * Knowledge and Information about Lithography | **Thomas Anhøj @danchip**  **Tine Greibe @danchip** | [Lithography](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography) |
| **Spin coater Gamma UV**  New spin coat was released in Marts | **Thomas Anhøj @danchip** | [Lithography/Coaters#Spin\_Coater:\_Gamma\_UV](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/Coaters#Spin_Coater:_Gamma_UV) |
| **Nitride etch in the AOE**  New Si3N4 recipe tested | **Berit Herstrøm @danchip** | [Silicon\_Nitride\_Etch\_using\_AOE](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/AOE_(Advanced_Oxide_Etch)/Silicon_Nitride_Etch_using_AOE) |

# Equipment Manuals updated in LabManager:

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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| **Manual for Developer-6" Bench** |
| **Manual for DUV Stepper.** |
| **Manual for Oven 250C** |
| **Manual for SÜSS Spinner-Stepper.** |
| **Manual for Spin Coater: Manual All Purpose** |
| **Manual for Developer TMAH Stepper.** |
| **Manual for LPCVD nitride furnace (6") E3** |
| **Manual for PECVD2** |
| **Manual for Physimeca** |
| **Manual for III-V Dielectric Evaporator** |
| **Manual for Black Magic PECVD (Carbon)** |
| **Manual for IBE/IBSD Ionfab 300** |
| **Manual for RCA clean** |
| **Manual for Anneal Bond furnace (C3)** |
| **Manual for Anneal Oxide furnace (C1)** |
| **Manual for Apox furnace (D1)** |
| **Manual for Gate Oxide furnace (A2)** |
| **Manual for Flip Chip bonder** |
| **Manual for probe station 3** |
| **Manual for Dektak 8** |
| **Manual for Nikon ECLIPSE L200 optical microscope** |
| **Manual for III-V profiler** |
| **Manual for SEM Supra 1** |
| **Manual for Dektak XTA New** |
| **Manual for Optical Profiler (Sensofar)** |
| **Manual for ellipsometer VASE** |
| **Manual for SEM Supra 2** |
| **User manual for E-Beam writer JBX-9500** |

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